

Comparison of Dislocation Characterization by Electron Channeling Contrast Imaging and Cross-Correlation Electron Backscattered Diffraction

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Abstract

In this work, the relative capabilities and limitations of electron channeling contrast imaging (ECCI) and cross-correlation electron backscattered diffraction (CC-EBSD) have been assessed by studying the dislocation distributions resulting from nanoindentation in body centered cubic Ta. Qualitative comparison reveals very similar dislocation distributions between the CC-EBSD mapped GNDs and the ECC imaged dislocations. Approximate dislocation densities determined from ECC images compare well to those determined by CC-EBSD. Nevertheless, close examination reveals subtle differences in the details of the distributions mapped by these two approaches. The details of the dislocation Burgers vectors and line directions determined by ECCI have been compared to those determined using CC-EBSD and reveal good agreement.

Keywords: ECCI, CC-EBSD, HR-EBSD, EBSD dislocation microscopy, Dislocations, Nanoindentation

1. Introduction

To understand how polycrystals deform and develop damage that leads to fracture, it is necessary to characterize the dislocations involved in the underlying plastic deformation. This dislocation content is made up of both the statistically stored dislocation (SSD) content, consisting of the portion of the overall dislocation density that effectively cancels itself out, i.e. due to dis-

25 location dipoles, and the geometrically necessary dislocations (GNDs) that are associated with
26 the crystal elastic strain gradients that develop through plastic deformation.

27 Traditionally, dislocation structures have been characterized using transmission electron mi-
28 croscopy (TEM) [1, 2]; however, TEM is plagued by a number of limitations associated with the
29 requisite thin foils. These can include difficult sample preparation, the potential for this sample
30 preparation to affect the apparent dislocation distributions, and limited observation volumes can
31 lead to poor statistical representation of the bulk.

32 Two significantly different techniques, electron channeling contrast imaging (ECCI) [3-
33 8] and cross-correlation electron backscattered diffraction (CC-EBSD) [9-12], are alternative
34 scanning electron microscopy (SEM) based approaches for characterizing dislocation structures.
35 Both of these techniques involve the examination of the near surface region of bulk samples and
36 require careful preparation of this surface region to be examined; nevertheless, eliminate many of
37 the limitations imposed by TEM thin foils. Surface preparation may be carried out either before
38 or after the imposed deformation.

39 In many respects, ECCI is carried out in the same manner as diffraction contrast TEM; that
40 is, imaging is achieved by setting up specific diffraction/channeling conditions. Instead of using
41 electron diffraction patterns to establish “2-beam” conditions as with TEM, ECCI relies on ei-
42 ther electron channeling patterns (ECPs), selected area channeling patterns (SACPs), or EBSD
43 patterns to establish electron channeling conditions [3, 8, 13]. This allows dislocations to be
44 characterized in terms of their Burgers vectors, \mathbf{b} , and line directions, \mathbf{u} , using the well estab-
45 lished $\mathbf{g} \cdot \mathbf{b} = 0$ and $\mathbf{g} \cdot \mathbf{b} \times \mathbf{u} = 0$ invisibility criterion, where \mathbf{g} describes the channeling condition
46 [3-5]. The dislocation line widths resolved by ECCI are similar to that offered by diffraction
47 contrast bright field imaging TEM, in the range of 10 to 12 nm[8]; however, TEM has the ad-
48 vantage of weak beam microscopy which decreases the dislocation line width, allowing TEM
49 to image areas with high dislocation densities [14, 15]. Conversely, ECCI has the advantage of
50 only having one free surface, so that image force [16] effects will not be as severe as in TEM thin
51 foils.

52 CC-EBSD, also referred to as high resolution or high angular resolution EBSD [10-12], is a
53 recently developed approach for mapping the GND content deduced from the Nye tensor [17].
54 Components of the Nye tensor come from elastic distortion gradients, determined from subtle
55 shifts in the EBSD patterns between neighboring pixels in an EBSD map [9, 10].

56 To fully exploit the ECCI and CC-EBSD approaches, it is important to establish the limita-
57 tions and relative capabilities of these techniques. A number of papers have shown how ECCI
58 and CC-EBSD can be used in complement of each other for a better analysis of dislocation
59 structures [12, 18, 19]. Vilalta-Clemente et al. [19] used CC-EBSD to characterize relatively
60 low density threading dislocations in as-grown InAlN epitaxial thin films, determining the indi-
61 vidual densities for pure edge, pure screw, and mixed threading dislocations using supplemental
62 information from ECCI; however, CC-EBSD and ECCI were carried out in different areas of the
63 same sample. This work also indicated that the sign of individual dislocations could be assessed
64 by CC-EBSD.

65 The objective of the present study is to directly compare dislocation structures characterized
66 by ECCI and CC-EBSD in the same area. These observations have been carried out by examining
67 the dislocation fields developed around nanoindentations in body centered cubic (bcc) Ta. Of
68 particular interest is the comparison between the information available from CC-EBSD and ECCI
69 and the establishment of CC-EBSD as a viable technique for the rapid determination of GND
70 densities, including its ability to characterize the specific slip systems involved in deformation.

71 2. Materials and Methods

72 To obtain sufficient sample quality for ECCI and CC-EBSD, a polycrystalline sample of
73 undeformed high purity Ta was metallographically prepared by grinding in steps down through
74 4000 grit SiC. A final polish was achieved using a 4 to 1 mixture of Struers OP-S and aqueous
75 30 % H₂O₂ on a Struers MD-Chem polishing cloth.

76 EBSD mapping of the polished material was carried out using a Tescan Mira 3 FEG-SEM
77 and an EDAX Hikari EBSD camera with a 480 × 480 pixel resolution and Orientation Imaging
78 Microscopy software (OIMTM). Nanoindentation was performed using an MTS Nano Indenter. A
79 25 × 22 array of nanoindents with 10 μm spacing was placed in the material, resulting in a large
80 number of indentations that were well-isolated from grain boundaries and a few indents located
81 close to grain boundaries. All of the indentation was performed with a maximum load of 4 mN and
82 a 10 s load- 10 s hold- 10 s unloading cycle. In order to avoid anisotropies associated with the tip
83 geometry, indentation was carried out using a spherical conical tip with an ~1 μm tip radius.

84 ECCI was carried out using the Tescan Mira 3 at 30 kV, a working distance of approximately
85 9 mm, an instrument spot setting of 6.1 nm, and a specimen current of 2.2 pA. Specific channel-

86 ing conditions were established using selected area channeling patterns (SACPs) facilitated by
87 the beam rocking function. Channeling imaging conditions were established through a combina-
88 tion of stage rotations and tilts determined using the TOCA software package [20].

89 EBSD patterns for cross-correlation analysis were collected around the same indentation re-
90 gions that were examined with ECCI, using step sizes of 100 nm, 50 nm, and 25 nm. Patterns
91 for cross-correlation were captured using the same Tescan SEM and EDAX Hikari EBSD sys-
92 tem. To acquire EBSD patterns with high contrast and low noise, necessary for cross-correlation
93 analysis, an instrument spot size of 20.0 nm and specimen current of 1.9 nA was used with an
94 exposure time of 0.1 sec. The patterns were not binned, but the 480×480 pixel resolution used
95 is comparable to 2×2 binning for cameras that have 1000×1000 pixel resolution.

96 Neighboring patterns were then cross-correlated in two directions using the OpenXY soft-
97 ware [21] to obtain the relative elastic distortion between the crystal lattices at the relevant scan
98 points [22]. The resulting distortion gradients provide 12 of the necessary 18 derivatives required
99 for the Nye tensor (the basis of continuum dislocation theory). Since the calculated GND density
100 is sensitive to the chosen scan step size, the software allows selection of a step size that is a mul-
101 tiple of the original scan step size; i.e. the cross-correlation calculation for distortion gradient
102 can be calculated between nearest neighbor points, next-nearest neighbor points, etc; resulting
103 in a range of effective step sizes. Ruggles et al. [22] discussed the necessity to find a range of
104 effective step sizes, where the associated GND densities become relatively constant in order to
105 accurately determine the “true” GND density; for Ta, they found this range to be between 100 nm
106 and 200 nm.

107 To determine the necessary effective step size for calculating GND densities for this work,
108 an EBSD scan was collected with a 25 nm step size and GND densities were calculated using
109 effective step sizes between 25 nm and 400 nm, shown in Fig. 1 as box plot distributions of
110 measured densities for each effective step size. At an effective step size of 175 nm, Fig. 1 shows
111 that GND densities enter a region where they become relatively constant, in agreement with the
112 results by Ruggles et al. [22].

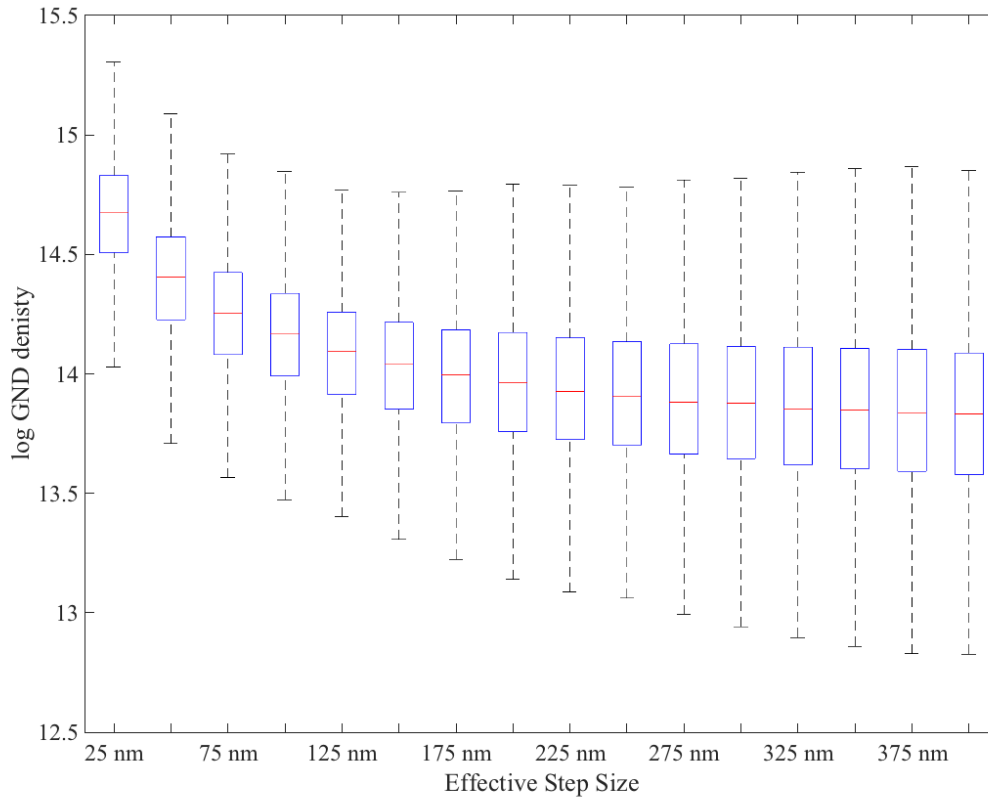


Figure 1: Box plots showing GND density distributions for effective step sizes between 25 nm and 400 nm.

113 3. Results

114 3.1. Dislocation Distributions

115 The dislocation distribution around an indent well isolated from the grain boundaries (a “single
 116 crystal” indent) in a grain oriented near $[0\ 1\ 1]$ was analyzed. Fig. 2a, which was produced
 117 by stitching multiple ECC images together, shows the general deformation fields around the in-
 118 dent. The strong intensity near the edge of the indentation can be attributed to the nominally
 119 tear shaped backscattered electron interaction volume escaping from the interior surface of the
 120 indent when the electron beam is scanned close to the edge of the indent. This effect is most
 121 likely complicated by the extensive deformation and localized rotations expected near the in-
 122 dent. Furthermore, the bright region appears asymmetrical due to the sample being tilted. Mov-

123 ing away from the high intensity region, dislocation fields extend from the indent in a number
124 of directions. Most of the dislocations in these fields appear as black/white dots, representing
125 dislocations roughly normal to the surface (examples shown in the dashed circle in Fig. 2a), but
126 some appear more extended due to their lines being more parallel to the surface (example shown
127 in dashed rectangle in Fig. 2a). More detailed images showing individual dislocations are illus-
128 trated in subsequent figures. The corresponding CC-EBSD calculated GND map (total GND
129 density), shown in Fig. 2b, displays dislocation distributions comparable to those in the ECC
130 image. The pixels that correspond to EBSD patterns that have a confidence index less than 0.15
131 are whited-out.

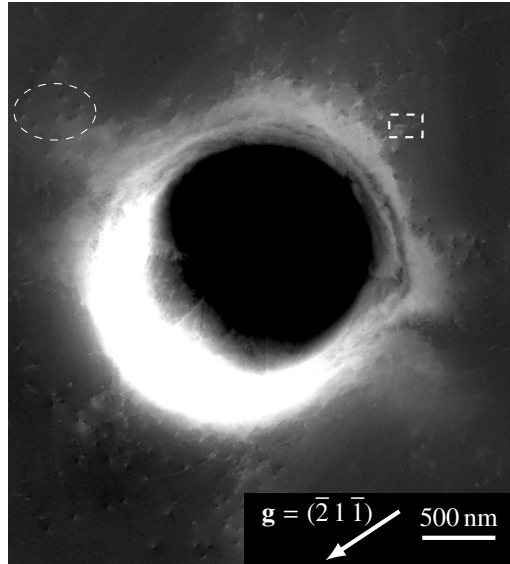
132 3.2. Dislocation Density Comparison

133 A more detailed comparison between the ECCI and CC-EBSD results, carried out on a neigh-
134 boring indent within the same grain, is shown in Fig. 3. Here the ECCI, Fig. 3a, shows a broad
135 band of dislocations extending to the upper left of the indent and a fainter band near the right
136 hand edge of the image, which curves to the left moving up in the image. Individual disloca-
137 tions can be readily discerned, with the majority of the dislocations appearing close to end-on in
138 the image. As before, there are also smaller numbers of dislocations with line directions more
139 parallel to the sample surface. A comparison of this image with the corresponding GND map
140 from CC-EBSD, Fig. 3b, again shows good agreement with the approximate locations of the
141 dislocations. Nevertheless, there is not an exact one-to-one correlation between ECCI and the
142 CC-EBSD images for reasons which will be discussed below.

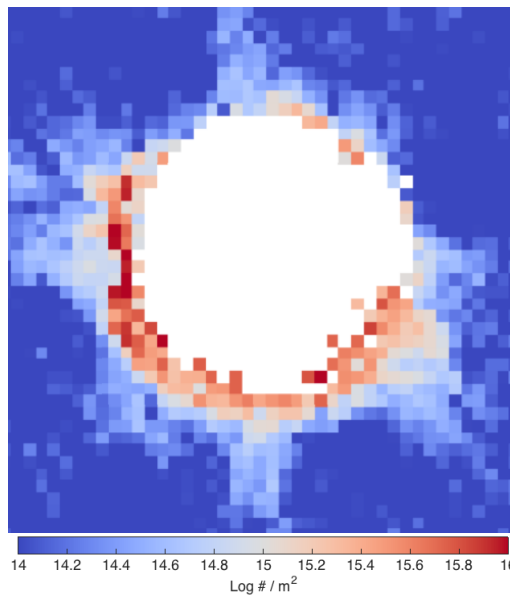
143 In order to facilitate a robust comparison, the dislocation locations determined from the ECC
144 image in Fig. 3a, have been plotted with the same step-size and color scale as the CC-EBSD map,
145 with the color scale now reflecting the number of dislocations per unit area of a pixel (an effective
146 dislocation density) in Fig. 3c. Regions where dislocations could not be reliably imaged, i.e. the
147 indent rim and inside the indent, were whited-out, seen in the lower right in Fig. 3c.

148 3.3. Dislocation Characterization Using ECCI

149 The dislocations imaged using ECCI were characterized using channeling contrast criteria
150 supplemented with the approximate line directions [5–8]. This analysis is focused on the region
151 outlined by white dashes in the upper left portion in Fig. 4a. This image, collected using the
152 $\mathbf{g} = (\bar{2} \ 1 \ \bar{1})$ channeling condition, shows what appears to be 64 dislocations in the circled region,



(a)



(b)

Figure 2: (a) Multiple ECC images stitched together showing dislocations generated from a nanoindentation in a grain of approximately $[0\ 1\ 1]$ orientation. (b) CC-EBSD GND map of the same area, collected with an EBSD scan step size of 100 nm and effective step size of 200 nm, showing dislocation distributions similar to that in the ECC image.

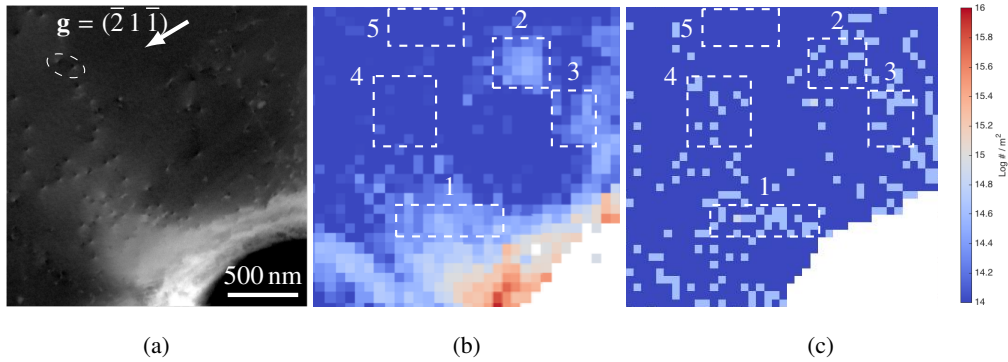


Figure 3: (a) ECC image of dislocations from the upper-left of the indented area. (b) CC-EBSD generated GND density map of the same area showing similar dislocation distributions, using a step size of 50 nm and an effective step size of 200 nm. (c) Dislocation density map calculated by counting dislocations in the ECC image.

153 (in a few cases the contrast is complicated and may represent more than one dislocation). Careful
 154 examination of these dislocations reveals that many of them have their characteristic black/white
 155 contrast in the same orientation, while others display reversed or rotated contrast. These differ-
 156 ences in contrast can indicate different Burgers vectors and/or edge or screw type dislocations
 157 [1, 23, 24]. Overall, 39 of the dislocations reveal the same contrast orientation, with four hav-
 158 ing reversed contrast. An additional 21 display different contrast orientation or are difficult to
 159 categorize due to weak contrast.

160 The six different channeling conditions used for the analysis shown in Fig. 4 were established
 161 by rotating and tilting the sample in conjunction with SACPs. The majority of dislocations do not
 162 go out of contrast with any of the channeling conditions, but the orientation of the black/white
 163 contrast varies with each channeling condition. The fact that the dislocations do not go out of
 164 contrast suggests that these are screw dislocations that are generally perpendicular to the surface.
 165 That is, despite the fact that $\mathbf{g} \cdot \mathbf{b} = 0$ for all of the \mathbf{g} vectors perpendicular to the screw line
 166 direction, the surface relaxation causes them to always be visible [2]. The white dashed arrows
 167 in Fig. 4 shows that the direction of the black to white contrast is roughly perpendicular to
 168 \mathbf{g} , consistent with the contrast expected from screw dislocations generally perpendicular to the
 169 surface [1, 23, 24].

170 The four possible $\langle 111 \rangle$ screw dislocation line directions in this region are each shown as an
 171 “x” on the stereographic projection with respect to the back-scatter detector, shown in Fig. 5a.

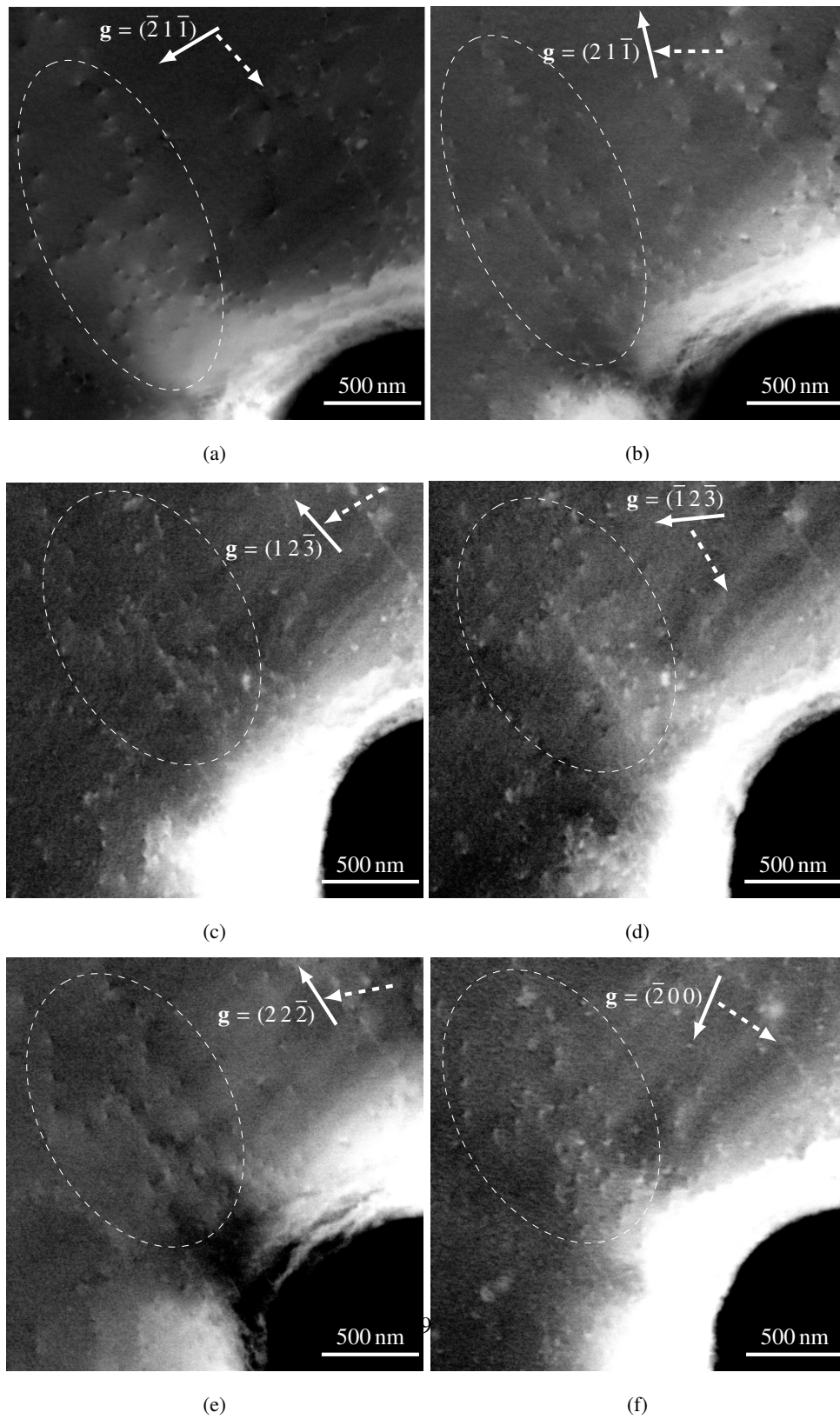


Figure 4: ECC images for the channeling conditions used for contrast analysis, with g indicated by the white arrows and the black to white contrast indicated by the white dashed arrows.

172 Two of these line directions, the $[1 \bar{1} 1]$ and $[\bar{1} \bar{1} 1]$, are nearly parallel and can be eliminated as
173 potential Burgers vectors/line directions of the dislocations that are close to perpendicular. To
174 distinguish between the two remaining possibilities, $[1 1 1]$ and $[\bar{1} \bar{1} 1]$ (which are 40° and 31°
175 from perpendicular to the beam axis, respectively), the sample was tilted 11° along $\mathbf{g} = (\bar{2} 1 \bar{1})$,
176 with the resulting orientation shown in the stereographic projection in Fig. 5b. This tilt would
177 cause $[1 1 1]$ screw dislocations to become more parallel to the detector (48° from the beam axis)
178 while $[\bar{1} \bar{1} 1]$ screw dislocations would become more perpendicular to the detector (27° from
179 the beam axis). The ECC image corresponding to this tilt, Fig. 5c, shows the dislocations now
180 projecting as lines that project (fade) towards the bottom of the image, indicating the majority
181 of the dislocations have line directions close to $[1 1 1]$. Combined with the sense of contrast
182 discussed above, it is reasonable to conclude that these most common dislocations are $a/2 [1 1 1]$
183 screw dislocations. It is worth noting that the other dislocations that display different black/white
184 contrast do not project in the same direction as the $a/2 [1 1 1]$ screws, suggesting they have
185 different line directions and Burgers vectors.

186 3.4. Dislocation Characterization Using CC-EBSD

187 In addition to the total dislocation density shown in previous sections, the Nye tensor de-
188 termined from CC-EBSD analysis may also be used to characterize the Burgers vector and
189 edge/screw character of the local dislocation density, as well as the slip plane of the edge disloca-
190 tions (the slip plane of screw dislocations is not determinable because it has no effect on the Nye
191 tensor) via the Nye-Kröner method. The GND densities were determined using the line length
192 minimization approach outlined by Ruggles et al. [25]. For this analysis, the smallest available
193 effective step size of 25 nm was employed to maximize the spatial resolution of the method. The
194 dislocation densities of each screw and edge dislocation possibility are shown in Fig. 6. The
195 dislocation densities were locally averaged to better show trends. In the highly deformed re-
196 gion near the indent, the Nye-Kröner method identifies the Burgers vector of dislocation content
197 where ECCI was incapable of resolving dislocations. In the region further from the indent, where
198 individual dislocations were discernible via ECCI, CC-EBSD also characterized the dislocation
199 content as being composed of screw dislocations with a $[1 1 1]$ Burgers vector. To highlight
200 agreement with the two methods, the dislocation density for the $[1 1 1]$ screw dislocation deter-
201 mined via CC-EBSD is shown in greater detail in Fig. 7.

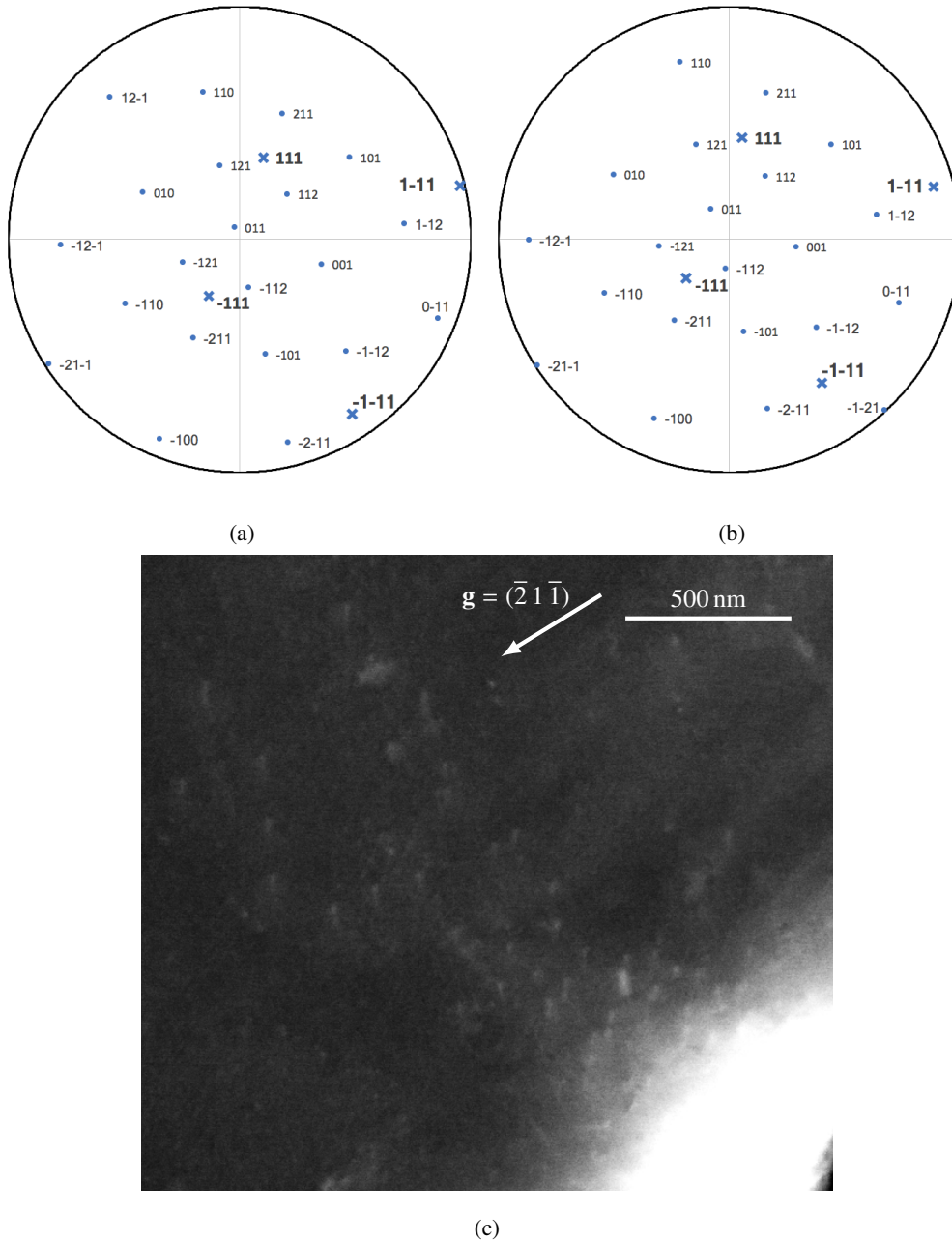


Figure 5: Stereographic projections (a) corresponding to Fig. 4a and (b) tilted 11° along the $\mathbf{g} = (\bar{2} \ 1 \ \bar{1})$ with each “x” being a line direction for the four possible screw dislocations. (c) ECC image with the same sample tilt as in (b), showing a projection of the dislocation line directions.

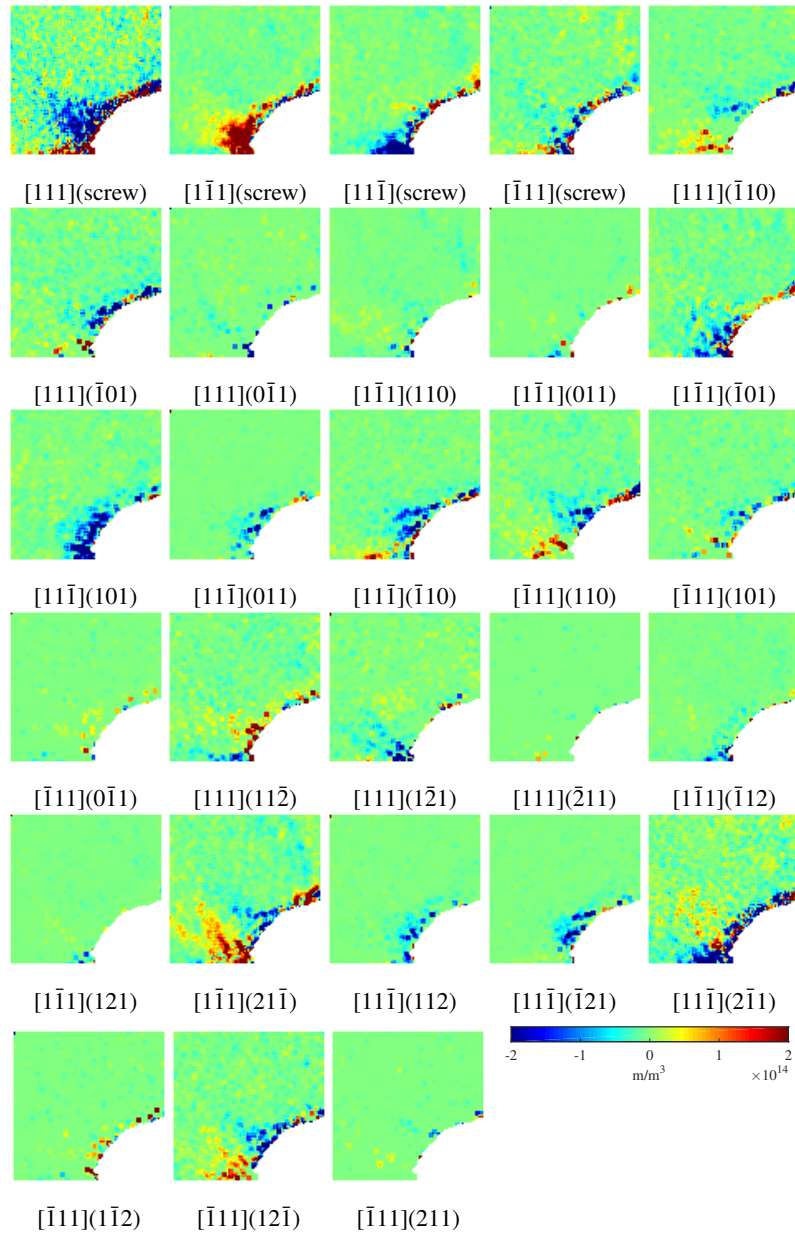
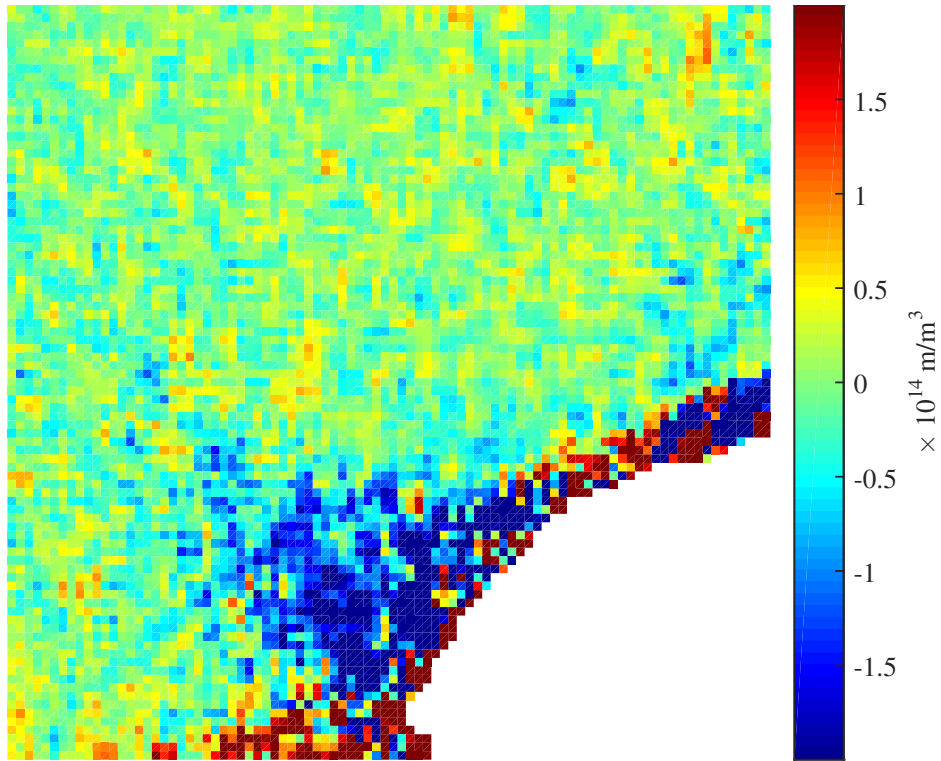


Figure 6: Dislocation density of each dislocation type according to CC-EBSD.



[111](screw)

Figure 7: Dislocation density of the screw dislocations with a Burgers vector of [111] determined by CC-EBSD.

202 A few caveats apply when employing the Nye-Kröner method at the limits of its spatial and
 203 dislocation density resolution (i.e. when there are countably few dislocations per area resolu-
 204 tion). First, all dislocation content is assumed to be a linear superposition of pure edge or pure
 205 screw dislocations. This means that dislocations of mixed character will be represented by su-
 206 perimposed fields. Additionally, at these low step sizes, noise effects are more dominant [22].
 207 One caveat often mentioned when interpreting dislocation density fields measured via CC-EBSD
 208 is not particularly cogent at the extremes of its resolution: the Nye-Kröner method only detects
 209 geometrically necessary dislocations. Because the length scale of the scan approaches that of
 210 dislocation dipole spacing, virtually all of the dislocations in the scan area may be thought of as
 211 geometrically necessary. Despite the challenges of employing CC-EBSD dislocation character-
 212 ization at a resolution suitable for comparison at the same length scale, the level of agreement
 213 with ECCI is striking.

214 4. Discussion

215 Qualitatively, there is good agreement between hotspots of the CC-EBSD GND results and
216 the locations of individual dislocations measured from ECCI. ECCI, however, has superior spa-
217 tial resolution, which allows for individual dislocations to be detected within a single grid square
218 while data from CC-EBSD is more diffuse and noisy. The diffusivity and noise from CC-EBSD
219 is due to the fact that a dislocation is treated as a continuum based on the strain field in the lattice,
220 causing the limited resolution of CC-EBSD to be controlled by the original step size at which
221 the EBSD data was acquired and the effective step size at which the GND map was calculated.
222 While ECCI has advantages for identifying individual dislocations at low densities, CC-EBSD is
223 advantageous because it is able to detect large lattice rotations and observe dislocations in high
224 deformation regions that are too densely packed for ECCI, i.e. around the rim of the indent.

225 To obtain a more robust quantitative comparison of the measurements presented in Fig. 3,
226 dislocation densities measured via ECCI and CC-EBSD were averaged for five separate regions.
227 In regions 1, 2, and 3, ECCI and CC-EBSD both detected dislocations, in region 4 only ECCI ob-
228 served distinct dislocations, and in region 5 no dislocations were observed using ECCI. For each
229 of these five regions, an average GND density from CC-EBSD was determined by averaging the
230 GND density associated with each pixel in the region, and presented in Table 1. Dislocation den-
231 sities from ECCI were determined by counting the number of dislocation intersections with the
232 surface. Dislocations were initially assumed to have line directions perpendicular to the surface,
233 but if dislocations are not normal to the counting area, dislocation densities are underestimated
234 [26]. To obtain corrected densities, the dislocation density should be multiplied by $\frac{1}{\cos(\theta)}$, where
235 θ is the angle between the line direction and the beam axis. Most of the dislocations in regions 1
236 and 4 were identified as [1 1 1] screw dislocations with a line direction 40° to the beam axis when
237 the sample was in the channeling condition for the ECC image in Fig. 3a. The dislocations for
238 regions 2 and 3 were not identified and are not all the same dislocation type but many of these
239 dislocations are likewise inclined. Since all line directions are possible, averaging the angles of
240 the 22 possible line directions (12 for {1 1 0} slip plane systems, 6 for {1 1 2} slip plane systems,
241 and 4 for screw dislocations) make with the beam axis, an average angle of 58° has been used
242 for calculating the dislocation density. For all five regions, Table 1 presents both the initial and
243 line direction corrected dislocation densities.

244 Due to the spatial resolution limitations of CC-EBSD as compared to ECCI, it is possible

Table 1: Comparison of CC-EBSD GND densities and ECCI dislocation densities for the 5 regions in Fig. 3.

Region #	CC-EBSD GND Density	ECCI Density	ECCI (Line Direction Correction)	ECCI (Dipole Correction)
1	$2.6 \cdot 10^{14} \text{ m}^{-2}$	$1.6 \cdot 10^{14} \text{ m}^{-2}$	$2.1 \cdot 10^{14} \text{ m}^{-2}$	$1.9 \cdot 10^{14} \text{ m}^{-2}$
2	$2.1 \cdot 10^{14} \text{ m}^{-2}$	$8.6 \cdot 10^{13} \text{ m}^{-2}$	$1.6 \cdot 10^{14} \text{ m}^{-2}$	No Dipoles
3	$1.7 \cdot 10^{14} \text{ m}^{-2}$	$1.1 \cdot 10^{14} \text{ m}^{-2}$	$2.2 \cdot 10^{14} \text{ m}^{-2}$	No Dipoles
4	$6.4 \cdot 10^{13} \text{ m}^{-2}$	$6.1 \cdot 10^{13} \text{ m}^{-2}$	$8.0 \cdot 10^{13} \text{ m}^{-2}$	No Dipoles
5	$5.2 \cdot 10^{13} \text{ m}^{-2}$	0 m^{-2}	0 m^{-2}	No Dipoles

245 that dipole dislocation pairs will fall within a given CC-EBSD step, canceling the contribution
246 to the dislocation density, i.e. on the local scale ECCI may resolve dipoles while CC-EBSD
247 may not. Significant dipole pairs are observed in the ECC images, for example in the small oval
248 in Fig. 3a. ECCI shows 22 dislocations in region 1 with one dislocation displaying reversed
249 contrast (i.e. opposite Burgers vectors). From the CC-EBSD perspective this dislocation will
250 cancel out with another closely spaced dislocation and neither will be accounted for, leaving a
251 net 20 dislocations in the CC-EBSD determined dislocation density. This effect is accounted for
252 in the Dipole Correction Column in Table 1. Dipoles were observed in region 1, but not observed
253 in regions 2 through 5.

254 The total dislocation density is made up of both GNDs and SSDs. Thus, as ECCI images
255 reveal both the GNDs and SSDs, one would expect that the ECCI measured density would be
256 greater than or equal to that determined by CC-EBSD. However, the results presented here do
257 not reflect this for regions 1 and 2. This may indicate that the comparison here is being carried
258 out in regions where the CC-EBSD GND density measurements are close to their noise floor.
259 Indeed, region 5 is an area where no dislocations were observed using ECCI, but the CC-EBSD
260 indicated a GND density average of $5.2 \cdot 10^{13} \text{ m}^{-2}$. This noise floor is near the CC-EBSD GND
261 density noise range suggested by the work of Jiang et al. [27] in which they measured the GND
262 density noise on single crystal Si. This noise is likely due to binning/resolution of the EBSD
263 camera [27], pattern quality due to EBSD scan rate [28], and the EBSD step size/effective step
264 size [22, 29]. Errors may also be associated with increased diffusiveness of the EBSD patterns

265 taken from areas with a higher density of dislocations, but it would be expected that this error
266 would be averaged out over a number of EBSD steps. Nevertheless, if the noise level indicated
267 by region 5 outlines an uncertainty level that is then applied to the measurements in the other
268 regions, the CC-EBSD and ECCI measurements appear quite close.

269 ECCI could also result in lower measured dislocation densities simply because some dislo-
270 cations may be in a zero contrast condition for the particular 2-beam channeling condition used,
271 i.e. $\mathbf{g} \cdot \mathbf{b} = 0$ and/or $\mathbf{g} \cdot \mathbf{b} \times \mathbf{u} = 0$. In this work, however, this was not the case as this effect was
272 accounted for by taking images at multiple channeling conditions and other dislocations do not
273 appear. CC-EBSD will never have dislocations that are “missed” due to this effect and will be
274 able to identify all of the dislocations that contribute to the GNDs.

275 Another potential limitation of ECCI is that at higher dislocation densities it becomes im-
276 possible to resolve the individual dislocations. This appears to be the case for the regions close
277 to the indent that appear very bright. CC-EBSD does in fact identify higher dislocation density
278 pixels in this near-indent region that appear only bright in ECCI. Overall, both CC-EBSD and
279 ECCI have some inherent limitations to determining dislocation densities, and users should be
280 aware of these restrictions when using these techniques.

281 **5. Conclusions**

282 In summary, ECCI and CC-EBSD reveal very similar dislocation distributions associated
283 with nanoindentation deformation. While there is not a one-to-one correlation between maps
284 from these two techniques, the dislocation densities measured by ECCI are generally similar to
285 those determined by CC-EBSD. The discrepancies between the two techniques may be in part
286 due to inferior spatial resolution of CC-EBSD, allowing for CC-EBSD to miss dipole arrange-
287 ments, and the potential for ECCI to miss dislocations that are either under invisibility conditions
288 or are in areas that have too many dislocations to image. Despite these minor discrepancies, the
289 strong correlation in distributions, densities, and characterization of dislocations determined by
290 the two techniques suggest that CC-EBSD can be used with confidence for characterizing GND
291 structures with higher dislocation densities than those that can be imaged using ECCI. At the
292 other extreme, this work suggests that CC-EBSD has the potential to resolve individual disloca-
293 tions but cannot do so at this time with high confidence in deformed metallic materials.

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